

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): KESSLER, Berthold et al.

Application No.:

Group:

Filed: April 25, 2002

Examiner:

For: METHOD AND SENSOR DEVICE FOR MONITORING A LASER MACHINING
OPERATION TO BE PERFORMED ON A WORK PIECE AS WELL AS LASER
MACHINING HEAD WITH A SENSOR DEVICE OF THIS KIND

L E T T E R

Assistant Commissioner for Patents
Box Patent Application
Washington, D.C. 20231

April 24, 2001
1739-0172P-SP
.

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the
applicant hereby claims the right of priority based on the following
application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
Germany	101 20 251.2	04/25/01

A certified copy of the above-noted application(s) is(are)
attached hereto.

If necessary, the Commissioner is hereby authorized in this,
concurrent, and future replies, to charge payment or credit any
overpayment to deposit Account No. 02-2448 for any additional fees
required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly,
extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By: Joe McKinney Muncy - re accepted
JOE MCKINNEY MUNCY

Reg. No. 32,334

P. O. Box 747

Falls Church, Virginia 22040-0747

Attachment
(703) 205-8000
/cqc